

**Form PTO-1449** (modified)

List of Patents and Publications

For Applicant's Information

Disclosure Statement

(Use several sheets if necessary)

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APPLICANT: Halimaoui et al.

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ART UNIT: 2822

**U.S. PATENT DOCUMENTS**

EXAM. INITIALS	REF. DES	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
OK	A1	5,021,354	6/1991	Pfiester			
OK	A2	5,106,768	8/1998	Kuo			

**FOREIGN PATENT DOCUMENTS**

EXAM. INITIALS	REF. DES	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION. YES/NO
OK	A3	JP 61016530	1/1986	JP			Abstract
OK	A4	WO 97 41593	11/1997	WO			

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**

OK	A5	Soleimani et al.; "Formation of Ultrathin Nitrided SiO <sub>2</sub> Oxides by Direct Nitrogen Implantation into Silicon"; <i>J. Electrochem. Soc.</i> , 1995, 42(10).					

EXAMINER: *Christy Hawacek*

DATE CONSIDERED: 2/20/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the patent owner.

Information Disclosure Statement--PTO 1449 (modified)